

EVIDENCE FOR PATCH EFFECT FORCES ON THE GRAVITY PROBE B GYROSCOPES



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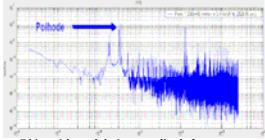
Experimental Observations Coupling of rotor-fixed frame to the GSS

Modulation at polhode frequency

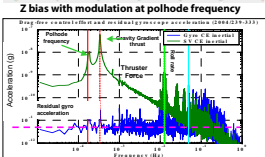
- Z (telescope axis) bias: 2×10^{-9} N
- Control effort at 1.3Hz spin: 30% of $\sim 2 \times 10^{-7}$ N
- Position & suspension voltage at 1.3Hz spin: ~ 60 nm_{pp}
- Control effort at 80 Hz spin: 30% of $\sim 10^{-8}$ N
- Orbit instability at polhode = orbit for drag free Gyro3

$\langle CE \rangle = 6 \times 10^{-9}$ N
CEPol = 6×10^{-9} N
VP ~ 100mV

Control effort modulated at polhode, 80 Hz spin



$F = C \cdot 2 \cdot V_{DC} \cdot V_p$
@ ω_{spin} OR $\omega_{polhode}$
 $V_p \approx 100$ mV



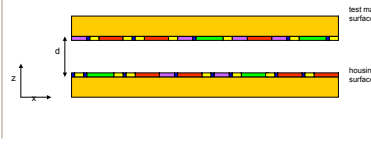
$\Delta V \sim 50$ mV -
100 mV

Possible Rotor-fixed Mechanisms

- Rotor geometry
 - Mass unbalance: ~ 10 nm (3×10^{-3} of gap)
 - ⇒ Small compared to > 10% effects
 - Surface waviness: ~ 10 nm (3×10^{-3} of gap)
 - ⇒ Small compared to > 10% effects
- Trapped flux interacting with housing
 - Three independent calculations (Todd Walters, Alex Silbergleit, Paul Worden)
 - ⇒ Effect too small by orders of magnitude
- Non uniform potential of rotor surface
 - ⇒ Patch effects consistent with data

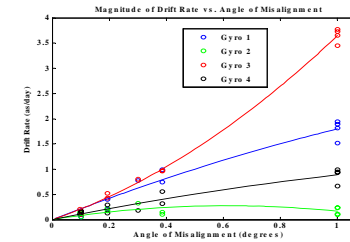
The Patch Effect

- Variation of electric potential over the surface
 - It can arise due to the polycrystalline structure
 - It can be affected by presence of contaminants
- Modeled as dipole layer
- Patch fields present on rotor and housing walls
- Cause forces and torques between surfaces



Effects and Solutions

- Misalignment torques
 - Orthogonal to misalignment
 - Fully separable from Relativity
- Polhode damping
 - Period and phase determined to high precision
- Spin-down 1μ Hz/hr
 - Spin-speed determined to high precision



The Patch Effect

Accurate pointing history for torque calibration
Guide star visible and occulted

Polhode period histories for gyros
From on-board HFFT

Dissipation in ground-plane resistor
From on-board HFFT

$$P_{in} = I_{in} \Delta V = 10^{-10} \text{ W } (\mu\text{Hz} / \text{hr})$$

$$P_{out} = \frac{1}{2} V_p^2 \left(\frac{R^2 \omega^2}{1 + R^2 \omega^2} \right)$$

$$V_p (\text{mV}) = 72 \cdot (\Delta \mu\text{Hz} / \text{hr})$$

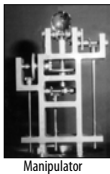
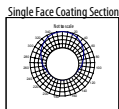
$$R = 300 \text{ } \Omega, C = 500 \text{ pF}, \omega = 500 \text{ sec}^{-1}$$

~70mV dipole for 1 μHz/hr spin-down
Spin-down rates 0.3-1.5 μHz/hr

Refinements in Data Analysis Process
Exact knowledge of spin-speed

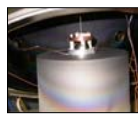
Rotor Fabrication

- Fused Quartz Sphere
 - Lapped and Polished
 - Roundness < 20 nm Peak to Valley
- Coating
 - Polycrystalline Niobium
 - Thickness 1.2 μm
 - < 30 nm Peak to Valley Variation
 - RF Diode Sputtered
 - 15 cm φ Target
 - 10 cm Target to Substrate Distance
 - 64 sequentially deposited partial coverage deposits
 - Pattern based on 20 faces + 12 vertices of an icosahedron

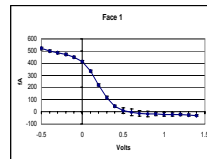


UV Work Function Mapping

- Work function ϕ is the potential difference between the Fermi level within a material and the field free vacuum state just outside the material.
- The energy of the emitted electron is $E_e = (hc/\lambda) - e\phi$
- Spatial variations in the work function causes variations in energy of photoelectrons.
- Map bias voltage for zero photoelectron current.

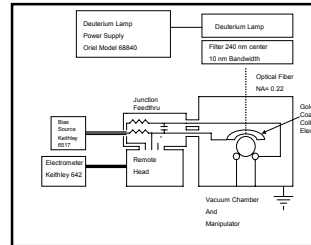


UV scan of rotor surface
240 nm center, 10 nm width
(5.10eV, 0.20eV)

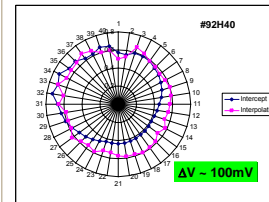


Measuring Apparatus in Vacuum Chamber

Block Diagram

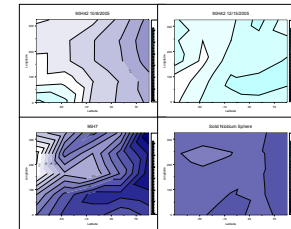


Mapping Plots



Great Circle Trace
Alternative Analytical Methods

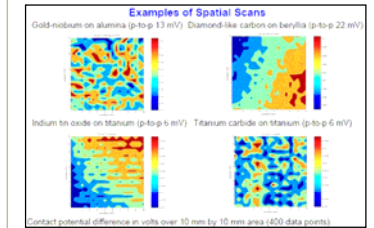
Deposition Pattern Contour Plots of Niobium Surfaces



Contour Interval 0.0425 V

Lessons Learned

- Surface characterization
 - Kelvin Probe measurements
 - UV photoemission measurements



- Large gaps
 - The stiffness is of the form:

$$K \epsilon_0 \frac{A v^2}{d^3}$$

A is the area,
v is the standard deviation of the potential fluctuations
d is the gap.
K is of order 1

